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JC06 Rec'd PCT/PTO 03 JUN 2005

DOCKET NO.: 4887/PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
IN THE MATTER OF THE NEW PCT NATIONAL PHASE PATENT APPLICATION

OF: Makoto OTSUKI et al. | USPS EXPRESS MAIL
USSN: NEW - TO BE ASSIGNED | EV 511 024 369 US
FILED: June 3, 2005 | JUNE 03 2005
FOR: Method of Manufacturing Single-Crystal
Semiconductor Wafers and Laser
Machining Apparatus Therefor

INTERNATIONAL SERIAL NO.: PCT/JP2004/008108
INTERNATIONAL FILING DATE: 10 June 2004

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COMMISSIONER FOR PATENTS
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ALEXANDRIA, VA 22313-1450

June 3, 2005

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

- 1) Pursuant to 37 C.F.R. 1.56, 1.97 and 1.98 applicants enclose a Form PTO-1449 and make of record the documents listed thereon. Copies of English Abstracts for references AB to AI and English Translations for references AC to AI are enclosed. A copy of the International Search Report issued on September 21, 2004 in the corresponding PCT International application is also enclosed. References AB to AI are not (and need not be) enclosed, because they were transmitted to the USPTO by the International Search Authority in the International Phase of this PCT Application.

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2) This statement is being filed concurrently with the above identified new PCT National Phase Application.

3) Reference AA is in English. References AB to AI are accompanied by English abstracts. References AC to AI are accompanied by English translations. Reference AG is a counterpart of AA. No further discussion of the references is necessary.

4) The relevance of references AB and AI was indicated by category in the International Search Report (A = technological background, general state of art; Y = relevant for obviousness when combined with another document; X = relevant for anticipation or obviousness when considered alone). Thereby a concise explanation of the relevance has been provided (see M.P.E.P. §609).

5) The Examiner is respectfully requested to consider all references of record, return an initialed copy of the enclosed Form PTO-1449 and ensure that all references of record are printed on any patent issuing from this application.

6) Favorable consideration and allowance of claims 1 to 40 are respectfully requested.

Respectfully submitted,
Makoto OTSUKI et al.
Applicant

By


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WFF:hc/4887
Encls.: postcard,
7 English translations,
8 English abstracts,
copy of International
Search Report

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Sheet 1 of 1 FIRST IDS LIST OF REFERENCES CITED BY APPLICANT (FORM PTO-1449)			Atty. Docket No. 4887/PCT	10 Serial No: to be assigned
DATED: June 3, 2005			Applicant: Makoto OTSUKI et al.	
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U. S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	C1.	Sub-C1.	Fil. Date
	AA	2002/0115235	08/2002	Sawada	-	-	-

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	C1.	Sub-C1.	Trans.	
							Yes	No
	AB	60-121091	06/1985	Japan	-	-	Abst	
	AC	06-039571	02/1994	Japan	-	-	Engl Trans & Abst	
	AD	06-076282	03/1994	Japan	-	-	Engl Trans & Abst	
	AE	11-000778	01/1999	Japan	-	-	Engl Trans & Abst	
	AF	2000-332078	11/2000	Japan	-	-	Engl Trans & Abst	
	AG	2002-324768	11/2002	Japan	-	-	=AA Engl Trans & Abst	
	AH	2003-103388	04/2003	Japan	-	-	Engl Trans & Abst	
	AI	2004-039808	02/2004	Japan	-	-	Engl Trans & Abst	

OTHER DOCUMENTS

EXAMINER'S SIGNATURE		DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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